Reply to Office Action of August 14, 2008

## **AMENDMENTS TO THE CLAIMS**

This listing of claims will replace all prior versions, and listings of claims in this application:

## **Listing of Claims:**

- 1. (Currently Amended) An optical system comprising a first optical unit and a first and a second sensor unit for sensing electromagnetic radiation, wherein the optical system is arranged such that incident electromagnetic radiation that originates from a scene outside of the optical system reaches the first sensor unit by passing via the first optical unit and by following a beam path from the first optical unit to the first sensor unit, wherein the optical system further comprises a micromirror matrix unit, which comprises a plurality of micromirror elements and which is arranged in the beam path, wherein the micromirror matrix unit is set in at least a first or a second state, wherein in the first state the micromirror matrix unit reflects the incident electromagnetic radiation which reaches the micromirror matrix unit from the first optical unit so that the electromagnetic radiation reaches the first sensor unit, wherein in the second state the micromirror matrix unit reflects the incident electromagnetic radiation which reaches the micromirror matrix unit from the first optical unit so that the electromagnetic radiation does not reach the first sensor unit, wherein the second sensor unit is arranged so that when the micromirror matrix unit is set in a state which is different from the first state, the micromirror matrix unit reflects the incident electromagnetic radiation which reaches the micromirror matrix unit from the first optical unit so that this electromagnetic radiation reaches the second sensor unit.
- 2. (Previously presented) An optical system according to claim 1, wherein the first sensor unit comprises a plurality of sensor elements and is arranged in an image plane in the optical system, which image plane is operable to constitute an image plane for the scene.
- 3. (Previously presented) An optical system according to claim 2, wherein the sensor elements are arranged as a two-dimensional array of sensor elements and wherein the optical system is constructed as a staring system.

Application No. 10/822,734 Docket No.: 69993-254124 Amendment dated October 31, 2008

Reply to Office Action of August 14, 2008

4. (Previously presented) An optical system, according to claim 3, wherein the image

plane, in which the first sensor unit is positioned, is arranged in the optical system so that it

constitutes an image plane for the scene when the scene is located at such a distance from the

optical system that rays from a point in the scene reach the first optical unit as at least substantially

parallel rays.

5. (Previously presented) An optical system according to claim 1, wherein the first

sensor unit is operable to sense radiation within the infra-red wavelength range.

6. (Canceled)

7. (Currently Amended) An optical system according to claim-61, wherein the micromirror

matrix unit is in the second state unit when it is set such that the incident electromagnetic radiation

reaches the second sensor unit.

8. (Previously presented) An optical system according to claim 7, wherein the second

sensor unit is of another kind than the first sensor unit, such that the second sensor unit is less

disposed to be disposed by electromagnetic radiation than the first sensor unit.

9. (Previously presented) An optical system according to claim 8, wherein the second

sensor unit is a quadrant detector.

10. (Previously presented) An optical system according to claim 9, wherein the second

sensor unit is arranged in the optical system so that it is not in an image plane for the scene, when

the scene is located at such a distance from the optical system that rays from a point in the scene

reach the first optical unit as at least substantially parallel rays.

4

Application No. 10/822,734 Docket No.: 69993-254124

Amendment dated October 31, 2008 Reply to Office Action of August 14, 2008

11. (Previously presented) An optical system according to claim 10, arranged to prevent

incident electromagnetic radiation from the scene being reflected back to the scene from the second

sensor unit.

12. (Previously presented) An optical system according to claim 11, further comprising

an optical isolator in the beam path between the first optical unit and the second sensor unit.

13. (Previously presented) An optical system according to claim 1, comprising at least

one reference source for emitting electromagnetic radiation of a known kind, wherein the reference

source is arranged so that electromagnetic radiation from the reference source reaches the first

sensor unit when the micromirror matrix unit is set in a state which differs from the first state.

14. (Previously presented) An optical state according to claim 13, wherein the reference

source is arranged so that electromagnetic radiation from the reference source reaches the first

sensor unit when the micromirror matrix unit is set in the second state.

15. (Previously presented) An optical system according to claim 14, further comprising a

control unit which controls at least the setting of the micromirror matrix unit.

16. (Previously presented) An optical system according to claim 15, wherein the control

unit is also arranged to control the sensing of the first sensor unit, so that the first sensor unit senses

at a plurality of occasions per second and wherein the control unit (32) is operable to control the

micromirror matrix unit (16) between the sensing occasions so that it is not in the first state.

17. (Previously presented) An optical state according to claim 16, further comprising

means for detecting if the optical system is exposed to scanning or destroying radiation, wherein the

control unit is arranged to control the micromirror matrix unit so that the first state is avoided when

said the detecting means has detected scanning or destroying radiation.

5

Application No. 10/822,734 Docket No.: 69993-254124 Amendment dated October 31, 2008

Reply to Office Action of August 14, 2008

18. (Previously presented) An optical system according to claim 17, wherein the control unit is arranged to, when the means has detected scanning or destroying the radiation control the micromirror matrix unit so that it reflects the incident electromagnetic radiation which reaches the micromirror matrix unit from the first optical unit so that the electromagnetic radiation reaches the

- 19. (Previously present) An optical system according to claim 18, wherein the control unit is arranged to individually control of setting of the mirror elements of the micromirror matrix unit so that an amount of electromagnetic radiation which is reflected by the micromirror matrix units towards the first sensor unit is controlled by the setting of the mirror elements of the micromirror matrix unit.
- 20. (Canceled)

second sensor unit.

- 21. (Canceled)
- 22. (Currently Amended) A target seeking system missile comprising an optical system comprising a first optical unit and a first and a second sensor unit for sensing electromagnetic radiation, wherein the optical system is arranged such that incident electromagnetic radiation that originates from a scene outside of the optical system reaches the first sensor unit by passing via the first optical unit and by following a beam path from the first optical unit to the first sensor unit, wherein the optical system further comprises a micromirror matrix unit, which comprises a plurality of micromirror elements and which is arranged in the beam path, wherein the micromirror matrix unit reflects the incident electromagnetic radiation which reaches the micromirror matrix unit from the first optical unit so that the electromagnetic radiation reaches the first sensor unit, wherein in the second state the micromirror matrix unit reflects the incident electromagnetic radiation which reaches the micromirror matrix unit from the first optical unit so that the electromagnetic radiation does not reach the first sensor unit, wherein the second sensor unit is

Application No. 10/822,734 Docket No.: 69993-254124

Amendment dated October 31, 2008

Reply to Office Action of August 14, 2008

arranged so that when the micromirror matrix unit is set in a state which is different from the first state, the micromirror matrix unit reflects the incident electromagnetic radiation which reaches the micromirror matrix unit from the first optical unit so that this electromagnetic radiation reaches the second sensor unit.

23. (Canceled)

7